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	Application No.	Applicant(s)	10
Notice of Allowability	10/658,238	KON ET AL.	
	Examiner	Art Unit	
	Phat X. Cao	2814	
The MAILING DATE of this communication appear All claims being allowable, PROSECUTION ON THE MERITS IS (of herewith (or previously mailed), a Notice of Allowance (PTOL-85) of NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIG of the Office or upon petition by the applicant. See 37 CFR 1.313	OR REMAINS) CLOSED in this apport of the appropriate communication GHTS. This application is subject to	olication. If not include will be mailed in due	ed course. THIS
1. This communication is responsive to 8/26/04.			
2. ⊠ The allowed claim(s) is/are <u>11-20</u> .			
3. X The drawings filed on <u>09 September 2003</u> are accepted by	the Examiner.		
4. Acknowledgment is made of a claim for foreign priority under a) All b) Some* c) None of the: 1. Certified copies of the priority documents have be completed as a claim for foreign priority under the certified copies of the priority documents have be completed as a claim for foreign priority under the certified copies of the priority documents have be completed as a claim for foreign from the certified copies of the certified copies of the priority documents have be completed as a claim for foreign from the complete foreign from the certified copies of the certified copies of the priority documents have be certified as the certified copies of the priority documents have be certified as the certified copies of the priority documents have be certified as the certified copies of the priority documents have be certified copies of the priority documents have be certified as the certified copies of the priority documents have be certified as a claim for foreign priority documents have be certified as a claim for foreign priority documents have be certified as a claim for foreign priority documents have be certified as a claim for foreign priority documents have be certified as a claim for foreign priority documents have be certified as a claim for foreign priority documents have be certified as a claim for foreign priority documents have be certified as a claim for foreign priority documents have be certified as a claim for foreign priority documents have be certified as a claim for foreign priority documents have be certified as a claim for foreign priority documents have be certified as a claim for foreign priority documents have be certified as certified as certified as a claim for foreign priority documents have be certified as c	been received. been received in Application No uments have been received in this in of this communication to file a reply ENT of this application. ted. Note the attached EXAMINER's reason(s) why the oath or declarate be submitted. on's Patent Drawing Review (PTO- Amendment / Comment or in the Comment or in the Comment of BIOLOGICAL MATERIAL in	national stage applicational stage application of the front (not the d).	quirements OTICE OF
 Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date 9/9/03 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material 	5. ☐ Notice of Informal P 6. ☐ Interview Summary Paper No./Mail Dat 7. ☒ Examiner's Amendn 8. ☒ Examiner's Stateme 9. ☐ Other	(PTO-413), e nent/Comment	

EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in paper filed 8/26/04 (Applicants elect claims 11-20 without traverse).

The application has been amended as follows:

IN THE CLAIMS:

Cancel non-elected claims 1-10

2. The following is an examiner's statement of reasons for allowance: the prior art of record fails to disclose the combination of a semiconductor light emitting device structure recited in the base claim, including the combination of the structure comprising: a ball-up preventive layer formed on a substrate; a bonding layer made of eutectic material and formed on the ball-up preventive layer; a metal layer formed on the bonding layer; a barrier layer formed on the metal layer; a first electrode formed on the barrier layer; a semiconductor light emitting structure formed on a surface including an upper surface of the first electrode; and a second electrode formed on a partial surface of the semiconductor light emitting structure.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably Application/Control Number: 10/658,238

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accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Phat X. Cao whose telephone number is (571) 272 The examiner can normally be reached on Monday - Thursday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Wael Fahmy can be reached on (571) 272-1705. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

PC

December 6, 2004

PHAT X. CAO
PRIMARY EXAMINER

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